



152 AF  
1/28/01

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Wilk *et al.*

Serial No.: 09/176,422

Filed: 10/21/98

For: Low Temperature Method for Forming a Thin, Uniform Oxide

Docket: TI-24742

*#10  
3-7-01  
C Brown*

Examiner: N. Berezny

Art Unit: 2823

## NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE BOARD OF PATENT APPEALS AND INTERFERENCES

February 27, 2001

Assistant Commissioner for Patents  
Washington, D. C. 20231

Examiner:

Applicant appeals to the Board of Appeals from the Primary Examiner's decision dated December 6, 2000, which finally rejected Claims 1 - 25.

Please charge the required fee to the deposit account of Texas Instruments Incorporated,  
03/07/2001 AJOHNS01 0000003 200668 09176422  
01 FC:119 Account No. 20-0668. Two additional copies of this notice are enclosed.

Respectfully submitted,

David Denker  
Reg. No. 40,987

Texas Instruments Incorporated  
P. O. Box 655474, MS 3999  
Dallas, Texas 75265  
(972) 917-4388  
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MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on
<i>February 28</i> , 2001.
<i>Tina Rendon</i>
Tina Rendon